

Message Text

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PAGE 01 TOKYO 12379 070930Z
ACTION COM-04

INFO OCT-01 EA-12 ISO-00 STRE-00 SSO-00 EB-08 STR-07
/032 W

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O 070920Z JUL 78
FM AMEMBASSY TOKYO
TO SECSTATE WASHDC IMMEDIATE 9424

UNCLAS TOKYO 12379

ATTN DAS HEGINBOTHAM FROM EMIN BUTTON

DEPT PASS COMMERCE FOR BIEPR/GLICK ALSO PASS ELECTRONICALLY
STR FOR BARREDA

E.O. 11652: N/A
TAGS: ETRD, BEXP, JA
SUBJECT: VISIT OF SEMICONDUCTOR INDUSTRY ASSOCIATION
(SIA) STUDY DIRECTOR VAN SAUN

REF: (A) TOKYO 12187, (B) STATE 154921, (C) TOKYO 10853

1. SUMMARY: SEMICONDUCTOR INDUSTRY ASSOCIATION (SIA) DIRECTOR OF TRADE POLICY VAN SAUN MET WITH MITI JULY 6 AND JETRO JULY 7 TO SOLICIT JAPANESE GOVERNMENT AND INDUSTRY SUPPORT FOR BROAD BASED FACT-FINDING TRADE STUDY GROUP (TSG) STUDY OF THE SEMICONDUCTOR INDUSTRY. GOJ WAS ATTENTIVE ALTHOUGH NON-COMMITTAL. FURTHER MEETINGS ARE EXPECTED WEEK OF JULY 10-14 WITH GOJ, JAPANESE INDUSTRY ASSOCIATIONS KEIDANREN, AND AMERICAN FIRMS REPRESENTED IN TOKYO. END SUMMARY.

2. MR. VAN SAUN MET WITH MITI OFFICIALS JULY 6 TO PRESENT PROPOSAL FOR TSG STUDY OF SEMICONDUCTOR INDUSTRY. HE BEGAN BY DISASSOCIATING HIS PRESENTATION FROM THE JUNE 7 AND 12 SHINN REPRESENTATION, AND EXPLAINED HIS PURPOSE
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PAGE 02 TOKYO 12379 070930Z

AS SEEKING JAPANESE GOVERNMENT AND INDUSTRY SUPPORT FOR A RECIPROCAL FACT-FINDING STUDY OF THE SEMICONDUCTOR INDUSTRY TO BE CARRIED OUT BY THE TRADE STUDY GROUP AND PARALLEL TO A SIMILAR STUDY ON A GLOBAL BASIS TO BE DONE UNDER THE AUSPICES OF THE U.S. INTERNATIONAL TRADE COMMISSION (ITC). NOTING THE RISE IN PROTECTIONIST SENTIMENTS IN THE U.S., VAN SAUN STRESSED THE IMPORTANCE OF U.S.

AND JAPANESE INDUSTRY COOPERATION IN SUCH A STUDY. VAN SAUN LAMENTED THE ATTITUDE OF A MINORITY OF MEMBERS IN THE U.S. INDUSTRY AS REPRESENTED IN THE RECENT FORTUNE MAGAZINE ARTICLE, AND EMPHASIZED THE CONGRESSIONAL AND BROAD INDUSTRY SUPPORT FOR AN OBJECTIVE STUDY THAT WOULD DEFUSE THE CURRENT FRUSTRATION IN THE U.S. AND JAPANESE INDUSTRIES. BOTH MITI AND JETRO WERE SERIOUS AND INTERESTED, ALTHOUGH REMAINED NON-COMMITTAL ABOUT POSSIBLE JAPANESE GOVERNMENT AND INDUSTRY PARTICIPATION AND TIMING. MITI REPS AGREED TO CONSIDER FURTHER MEETINGS BETWEEN VAN SAUN AND MITI, JETRO, JAPAN ELECTRONIC INDUSTRIES ASSOCIATION (EIAJ), INDIVIDUAL JAPANESE FIRMS, KEIDANREN, AND OTHERS. MANSFIELD

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Message Attributes

Automatic Decaptioning: X
Capture Date: 01 jan 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: INDUSTRY, VISITS, STUDIES, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Draft Date: 07 jul 1978
Decaption Date: 01 jan 1960
Decaption Note:
Disposition Action: n/a
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01 jan 1960
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1978TOKYO12379
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: N/A
Errors: N/A
Expiration:
Film Number: D780278-1185
Format: TEL
From: TOKYO
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1978/newtext/t19780783/aaaacsiq.tel
Line Count: 75
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 42436479-c288-dd11-92da-001cc4696bcc
Office: ACTION COM
Original Classification: UNCLASSIFIED
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: n/a
Previous Handling Restrictions: n/a
Reference: 78 TOKYO 12187, 78 STATE 154921, 78 TOKYO 10853
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 29 mar 2005
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: N/A
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2081101
Secure: OPEN
Status: NATIVE
Subject: VISIT OF SEMICONDUCTOR INDUSTRY ASSOCIATION (SIA) STUDY DIRECTOR VAN SAUN
TAGS: ETRD, BEXP, JA, US, (VAN SAUN)
To: STATE
Type: TE
vdkgvwkey: odhc://SAS/SAS.dbo.SAS_Docs/42436479-c288-dd11-92da-001cc4696bcc
Review Markings:
Sheryl P. Walter
Declassified/Released
US Department of State
EO Systematic Review
20 Mar 2014
Markings: Sheryl P. Walter Declassified/Released US Department of State EO Systematic Review 20 Mar 2014